

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

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Title of Invention

METHOD AND SYSTEM TO COMPENSATE FOR LAMP
INTENSITY DIFFERENCES IN A PHOTOLITHOGRAPHIC
INSPECTION TOOL

Application Number : 10/749887
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First Named Applicant: David Dixon
Attorney Docket Number: CT004
Art Unit: 1756
Examiner:



Search string: (3749496 or 4806776 or 5039868 or 5335293 or 5581074 or 5835220 or 5917588
or 5943437 or 5995217 or 6064759 or 6078386 or 6151064 or 6337488 or 6356347
or 6376852 or 6515742 or 6570650 or 20020009220 or 20030011761 or
20030059103 or 20030086080).pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	3749496	1973-07-31	Hietanen et al.		356	73
	2	4806776	1989-02-21	Kley		250	560
	3	5039868	1991-08-13	Kobayashi et al.		250	572
	4	5335293	1994-08-02	Vannelli et al.	A	382	17
	5	5581074	1996-12-03	Yoshida	A	250	205
	6	5835220	1998-11-10	Kazama et al.	A	356	369
	7	5917588	1999-06-29	Addiego	A	356	237
	8	5943437	1999-08-24	Sumie et al.	A	382	149
	9	5995217	1999-11-30	Watanabe	A	356	237
	10	6064759	2000-05-16	Buckley et al.	A	382	154
	11	6078386	2000-06-20	Tsai et al.	A	356	237.1
	12	6151064	2000-11-21	Connolly et al.	A	348	93
	13	6337488	2002-01-08	Okawauchi	B1	250	559.05
	14	6356347	2002-03-12	Watanabe et al.	B1	356	369
	15	6376852	2002-04-23	Watanabe et al.	B2	250	559.22
	16	6515742	2003-02-04	Ruprecht	B1	356	237.4
	17	6570650	2003-05-27	Guan et al.	B1	356	237.4

US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
	1	20020009220	2002-01-24	Tanaka	A1	382	145
	2	20030011761	2003-01-16	Gilat-Bernshtein et al.	A1	356	237.4
	3	20030059103	2003-03-27	Shiomi et al.	A1	382	144
	4	20030086080	2003-05-08	Guan et al.	A1	356	237.1

Signature

Examiner Name	Date